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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 3771**
Yoichiro NUMASAWA et al. : Docket No. 2003_1106A
Serial No. 10/642,619 : Group Art Unit 1754
Filed August 19, 2003 : Examiner Ngoc Yen M. Nguyen
APPARATUS AND METHOD FOR :
MANUFACTURING HALOGEN GAS AND : THE COMMISSIONER IS AUTHORIZED
HALOGEN GAS RECOVERY AND : TO CHARGE ANY DEFICIENCY IN THE
CIRCULATORY SYSTEM : FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

PATENT OFFICE FEE TRANSMITTAL FORM

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Attached hereto is a check in the amount of \$450.00 to cover Patent Office fees relating to filing the following attached papers:

Petition for Extension of Time \$450.00

A duplicate copy of this paper is being submitted for use in the Accounting Division, Office of Finance.

The Commissioner is authorized to charge any deficiency or to credit any overpayment associated with this communication to Deposit Account No. 23-0975, with the EXCEPTION of deficiencies in fees for multiple dependent claims in new applications.

Respectfully submitted,

Yoichiro NUMASAWA et al.

By David M. Ovedovitz
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June 23, 2005

[Check No. 68917]
2003_1106A



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APPARATUS AND METHOD FOR :
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RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
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Sir:

Pursuant to the requirement contained in the Office Action mailed March 24, 2005, the period for response to which having been extended by two months to June 24, 2005, Applicants hereby elect invention I, claims 1-7, drawn to a process for manufacturing halogen gas.

In view of this election, a full examination on the merits of the present application is respectfully requested.

Respectfully submitted,

Yoichiro NUMASAWA et al.

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